

**CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)**Applicant(s): **Anatoly Leontievich Vikharev et al.**

Docket No.

**IOAP 4.1-1**

Application No.	Filing Date	Examiner	Customer No.	Group Art Unit
<b>10/526,800</b>	<b>March 7, 2005</b>	<b>Rakesh Kumar Dhingra</b>	<b>35684</b>	<b>1792</b>

Invention: **HIGH VELOCITY METHOD FOR DEPOSITING DIAMOND FILMS FROM A GASEOUS PHASE IN SHF DISCHARGE PLASMA AND DEVICE FOR CARRYING OUT SAID METHOD**I hereby certify that this **Interview Summary***(Identify type of correspondence)*

is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope

addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on

**December 4, 2009***(Date)***Kelley L. Holcomb***(Typed or Printed Name of Person Mailing Correspondence)**(Signature of Person Mailing Correspondence)***Note: Each paper must have its own certificate of mailing.**